



In2p3

# First Test Results Of MIMOSA-26, A Fast CMOS Sensor With Integrated Zero Suppression And Binary Output

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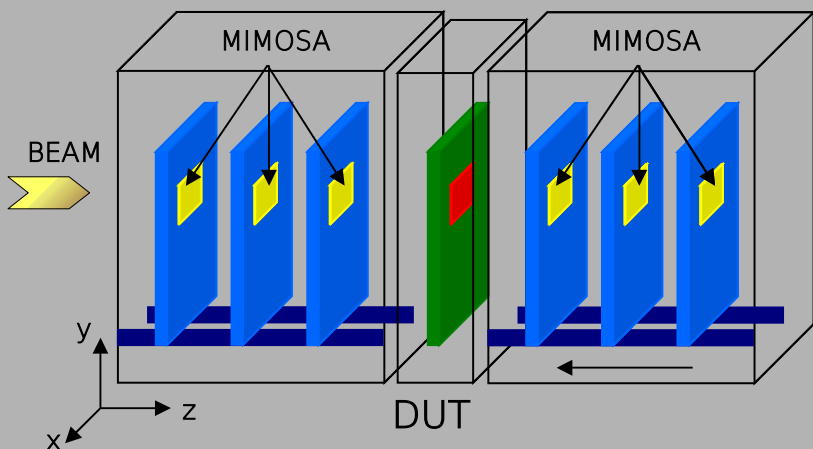
On behalf of the groups:

- IPHC, Strasbourg
- IRFU-CEA, Saclay

- Motivations for such a sensor
- MIMOSA 26 architecture
- Tests and results
- Further developments
- Integration studies

## ■ EUDET

- x 6<sup>th</sup> Framework Programme of EC
  - Infrastructure supporting detector R&D for ILC
  - See I.Gregor's talk on Thursday N45-2
- x High resolution pixellated beam telescope
  - Track extrapolation @ DUT  $\sigma \sim 2\mu\text{m}$
  - Sensitive area  $2\text{cm}^2$  with 1 dim  $\sim 2\text{cm}$
  - Binary readout allowing 10 Kframes/s
  - Up to  $10^6$  hits/ $\text{cm}^2/\text{s}$
- x Final telescope for 2009



## ■ Vertex Detectors

- x "Common" specifications
  - High granularity: pitch  $< 30\mu\text{m}$
  - Fast: readout  $\sim 100\text{-}200\ \mu\text{s}$
  - Low occupancy: few %
  - Low material budget:  $\ll 10^{-2} X_0$
  - Low power dissipation:  $100\ \text{mW}/\text{cm}^2$ ,  $\sim 30^\circ\text{C}$  operation
  - Mild radiation tolerance  $< \text{Mrad}$  and  $< 10^{12} n_{\text{eq}}/\text{cm}^2$
- x STAR @ RHIC - 2010
- x CBM @ FAIR - 2012
  - Readout  $< 10\ \mu\text{s}$
  - Several Mrads and  $10^{14} n_{\text{eq}}/\text{cm}^2$
- x ILD @ ILC  $> 2012$ 
  - First layer readout  $\sim 25\ \mu\text{s}$

→ Development of a fast binary readout CMOS sensor

## ■ Fabrication

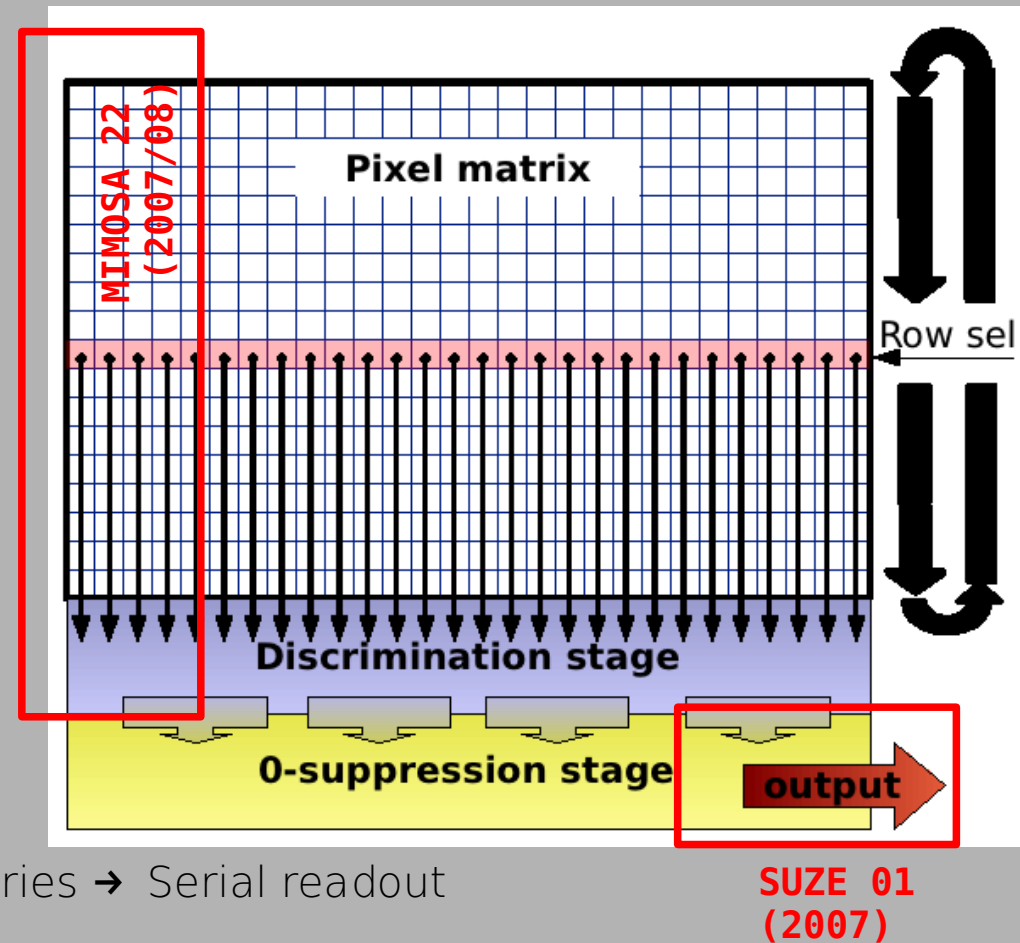
- x CMOS 0.35  $\mu\text{m}$  OPTO process
- x Designed in 2008, Return from foundry early 2009

## ■ Column parallel readout

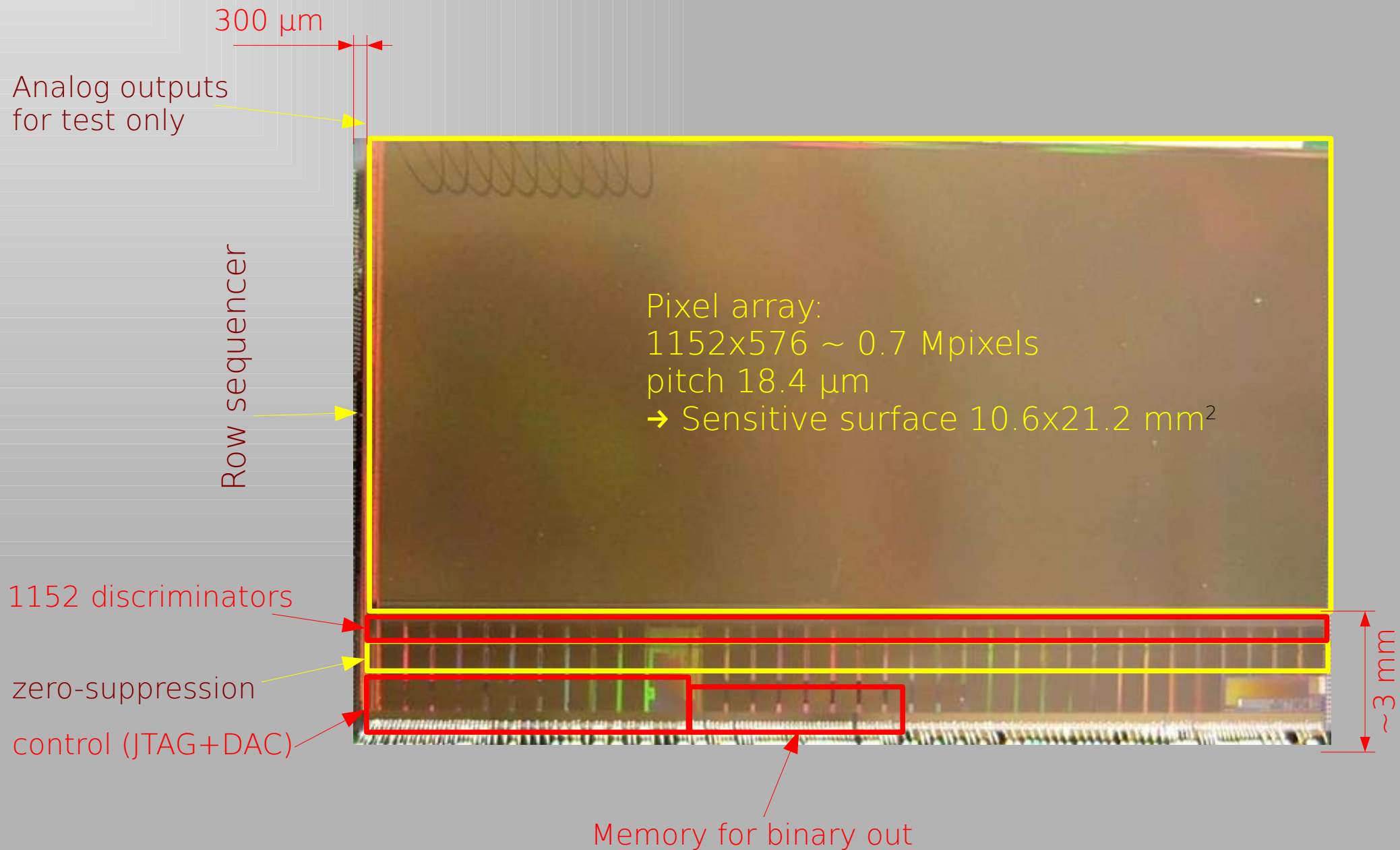
- x Rolling-shutter mode
  - 80 Mhz clock → 112  $\mu\text{s}$  integration
- x One pixel contains:
  - Amplification
  - Double Sampling
- x 1 discriminator per column with
  - Offset compensation
  - Correlated Double Sampling

## ■ Zero-suppression stage

- x Parallel sparse data scan → Two memories → Serial readout
- x Data compression factor x10 to 1000 depending on occupancy



# MIMOSA 26 architecture



## ■ Laboratory tests

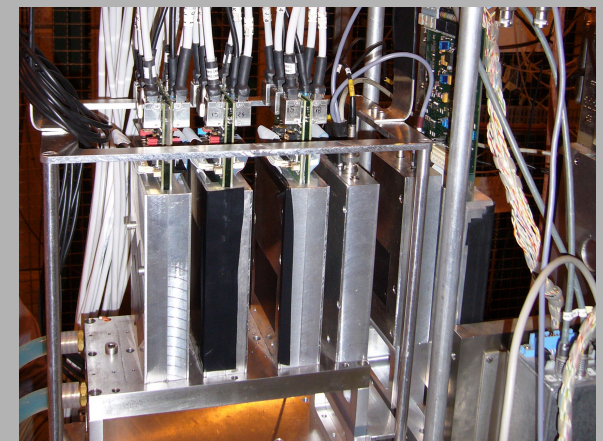
- x Operation at 20°C
- x Clock 20 → 80 Mhz
- x Noise measurements...
- x Charge collection efficiency with analog test outputs identical to MIMOSA 22
- x Validation of zero-suppression with input patterns
- x Power dissipation (static) 300 mW/cm<sup>2</sup> independent on #rows (dynamic ~200 mW @ 1% occupancy)

## ■ Sensors

- x Non-irradiated
- x Over 30 sensors from 2 wafers tested in lab
  - Yield for functional sensors ~90%
- x 1 wafer thinned down to 120 μm

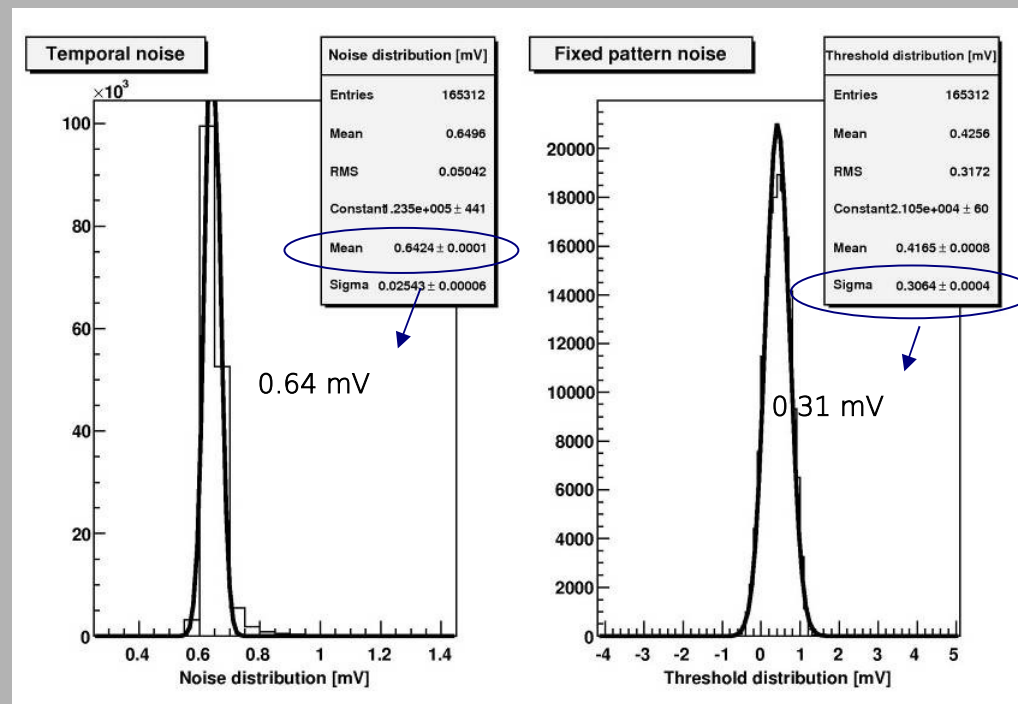
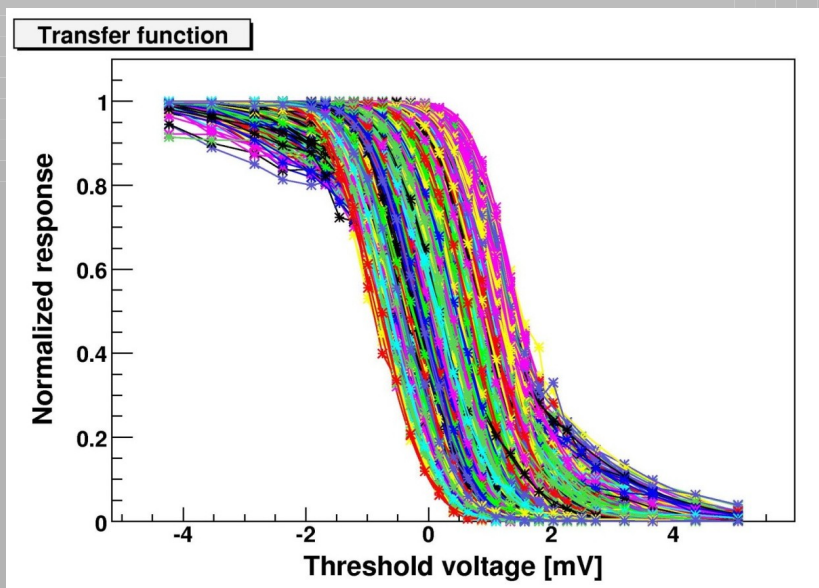
## ■ Beam tests

- x SPS beam: 120 GeV π<sup>-</sup>
- x 6 sensors used in beam test = 5 reference planes → track + 1 DUT
- x Operation at 20°C
- x Clock 20 and 80 Mhz
- x 90-20 deg incidence
- x Threshold scan 4.5 to 10 x noise
  - Fake hit rate
  - Efficiency
  - spatial resolution

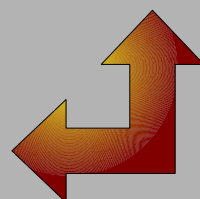


## ■ Tests in lab

- x 20 MHz to 80 Mhz
- x Temporal noise mainly due to pixels: 0.6-0.7 mV
- x Fixed pattern noise mainly due to discriminator: 0.3-0.4 mV
- x ENC ~ 13-14 e<sup>-</sup> equivalent to MIMOSA 22 noise

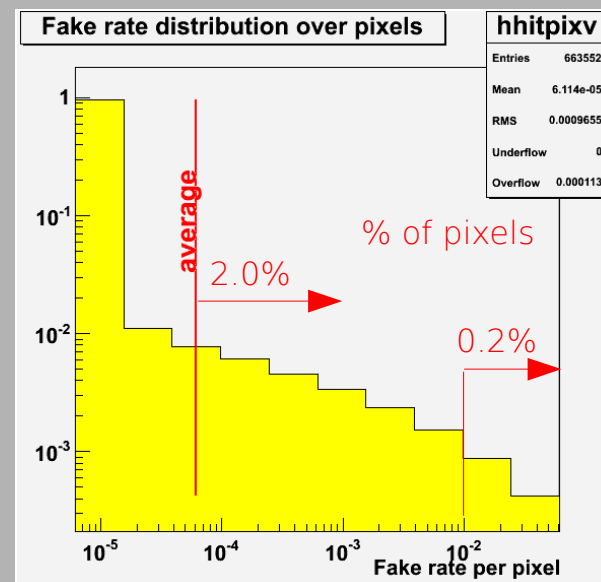


For 1/4 of the full matrix

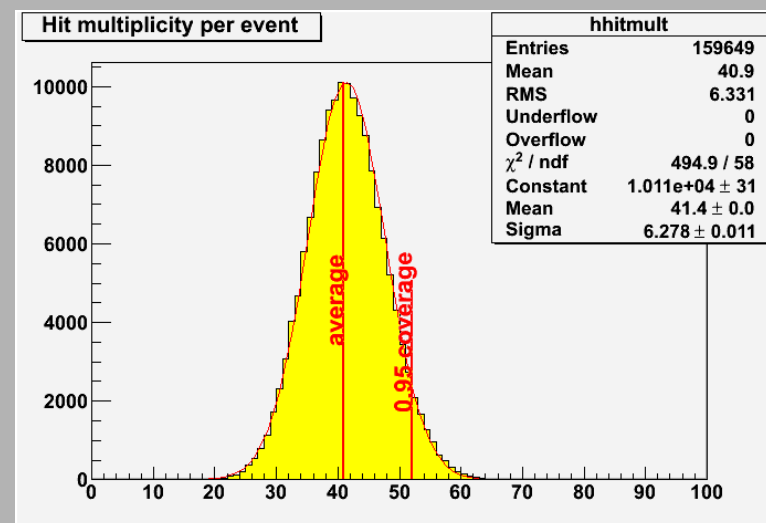


## ■ Fake hit rate

- x Fake hit = Single pixel firing with no beam
- x Counts over the full matrix over ~150000 frames
- x Gaussian behavior per event

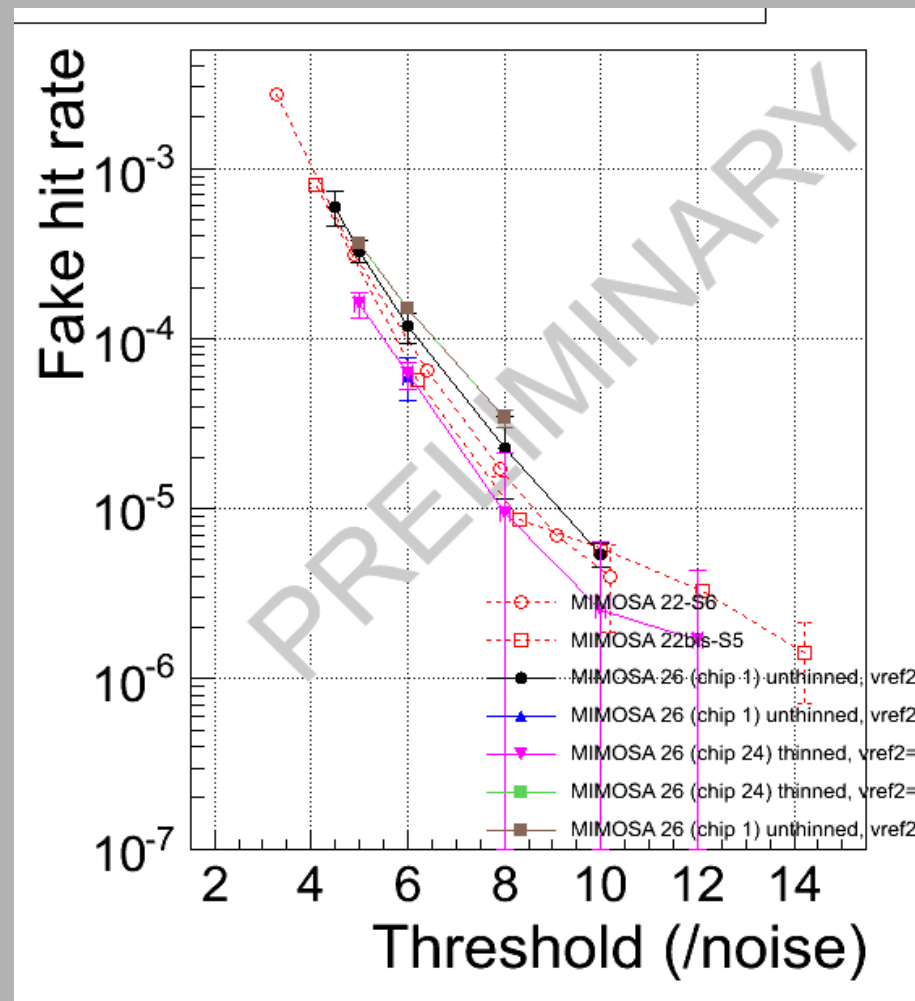


Threshold ~ 6xnoise



## ■ Fake hit rate

- x Fake hit = Single pixel firing with no beam
- x Counts over the full matrix over  $\sim 150000$  frames
- x Gaussian behavior per event



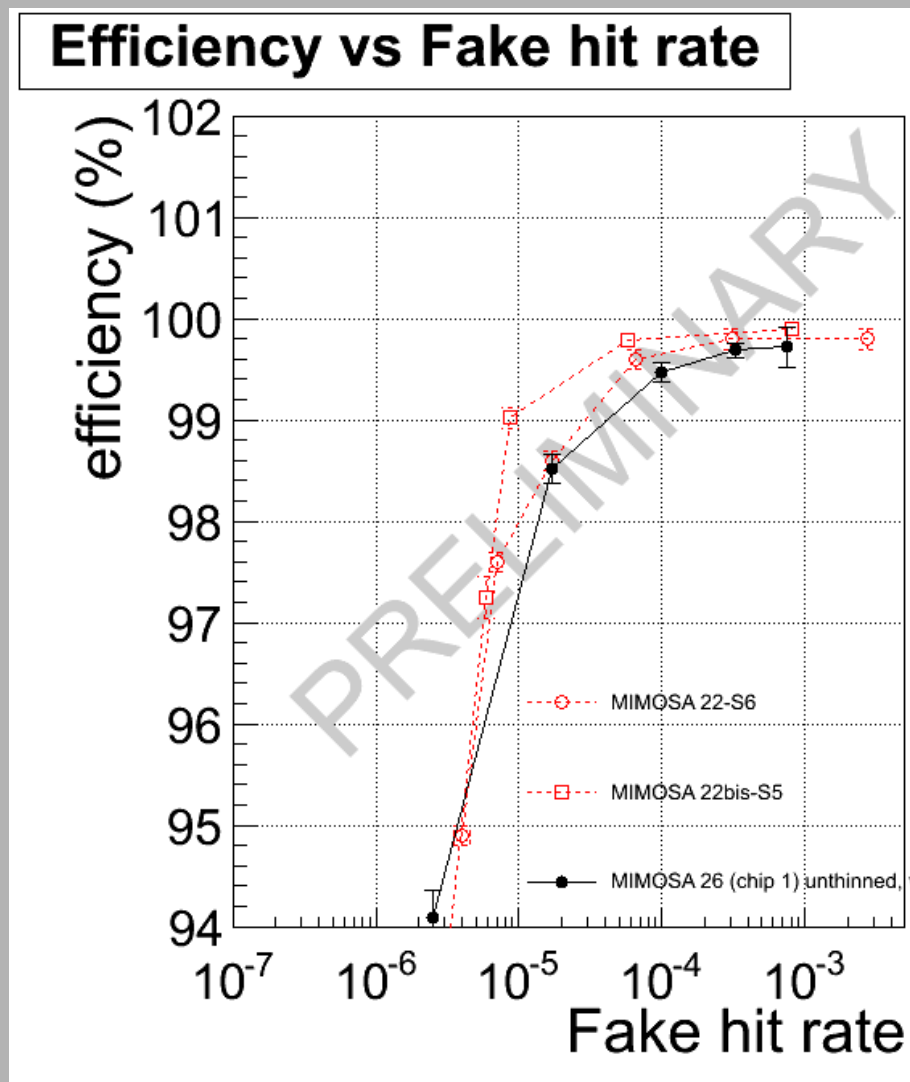


## ■ Fake hit rate

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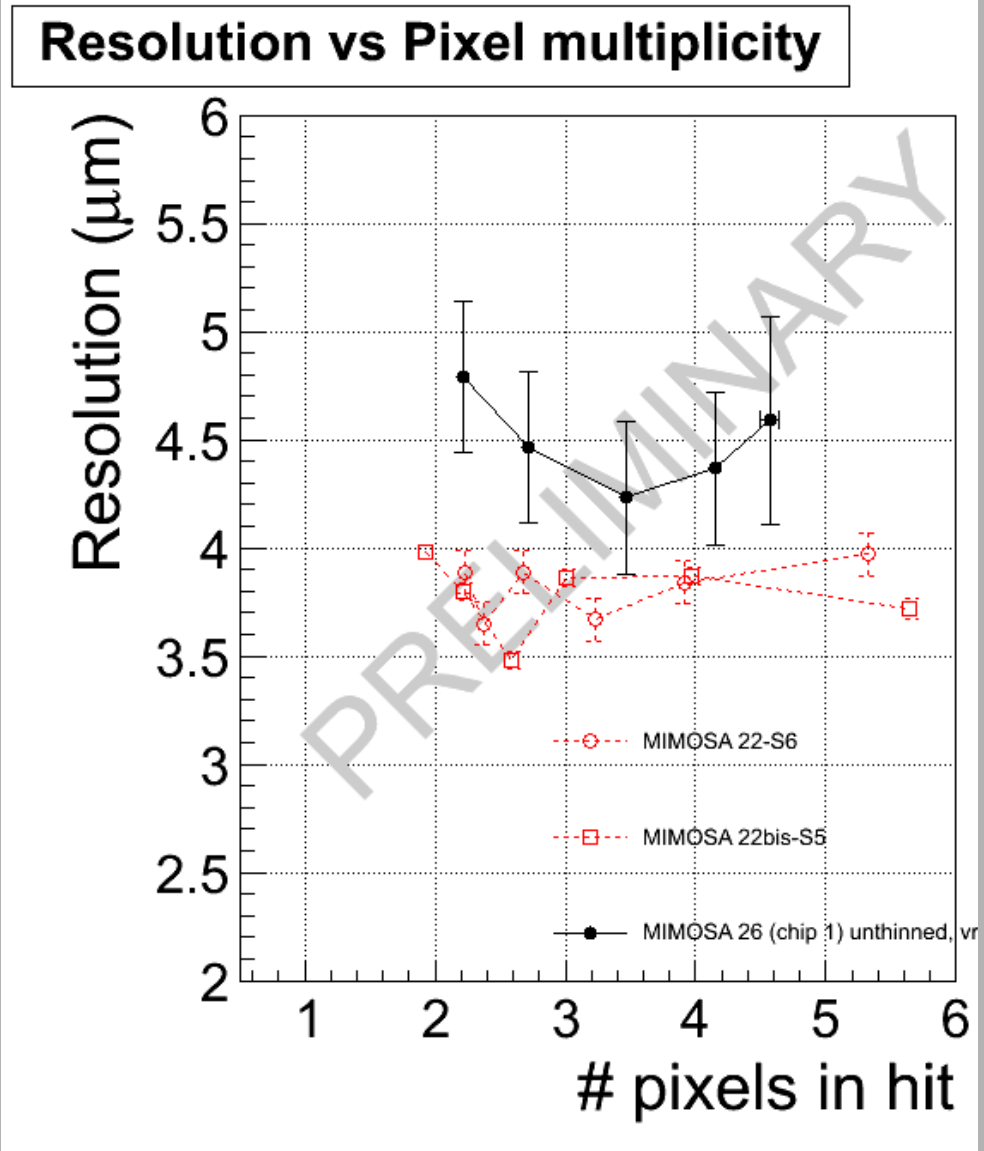
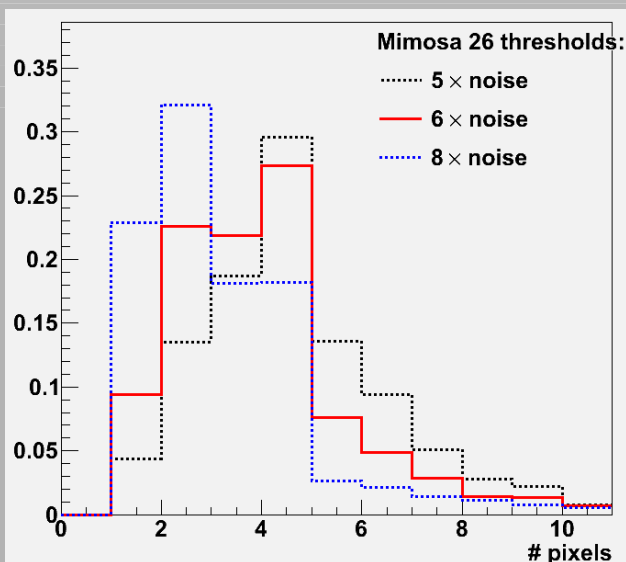
## ■ Efficiency

- x Efficiency defined as:  
#tracks assoc. with a hit  
over total #tracks
- x Fake rate computed in the scintillator area
- x Not yet checked over the full sensor area but only  $4 \times 4 \text{ mm}^2$
- x Efficiency 99.5% reachable for fake rate  $10^{-4}/\text{pixel}$



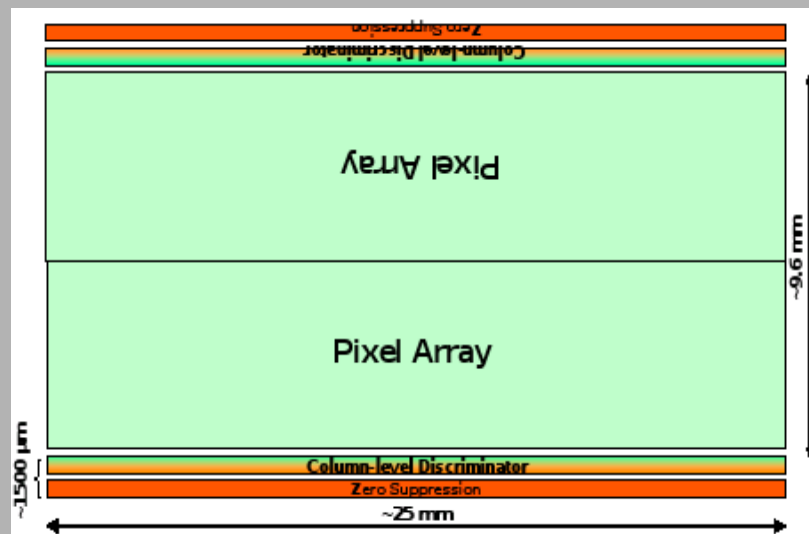
## ■ Still very preliminary

- x Due to rough position algorithm
- x Track extrapolation @ DUT  
 $\sigma = 2.1 \pm 0.4 \mu\text{m}$
- x Prelim. resolution of Mimosa26 worst by  $0.5 \mu\text{m}$  / MIMOSA 22
  - Though average  $\langle \# \text{pixels/cluster} \rangle$  is the same
  - Effect of inhomogeneities in a large matrix ?



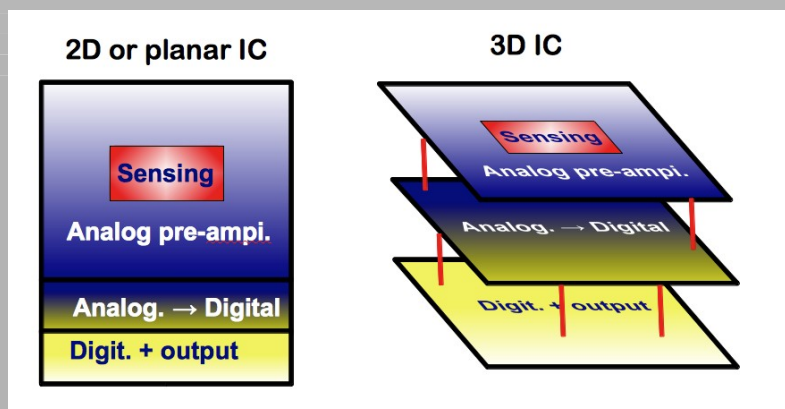
## ■ Sensor architecture

- x Two sided readout and/or elongated pixels
  - Increase **readout speed**
- x Replace discri. with few bits ADCs
  - Same resolution for larger pixel pitch
- x 3D integrated circuits
  - Increase **readout speed**
  - Decrease **dead areas**
  - Optimization of techno. per function



## ■ Process technology

- x Lower feature size  $\leq 0.18 \mu\text{m}$ 
  - Increase **readout speed**
  - Decrease **dead areas**
  - Decrease **power dissipation**
- x High resistivity epitaxial layer
  - Improve tolerance / non-ioniz. rad.



See Wojciech Dulinsky's talk (same session N22)  
 See Yavuz Degerli's poster (session N25-167)

- In a beam telescope

- x PCB enough for 1 or 2x2 sensors

- In a vertex detector

- x Opposite constraints

- Electrical connection + Mechanical support + Power dissipation
    - Material budget

- x ILC goals

- Single point resolution  $\sim 3\mu\text{m}$
    - Double sided ladder
    - Material budget  $< 0.3\% X_0$

# Integration topic

## ■ In a beam telescope

- x PCB enough for 1 or 2x2 sensors

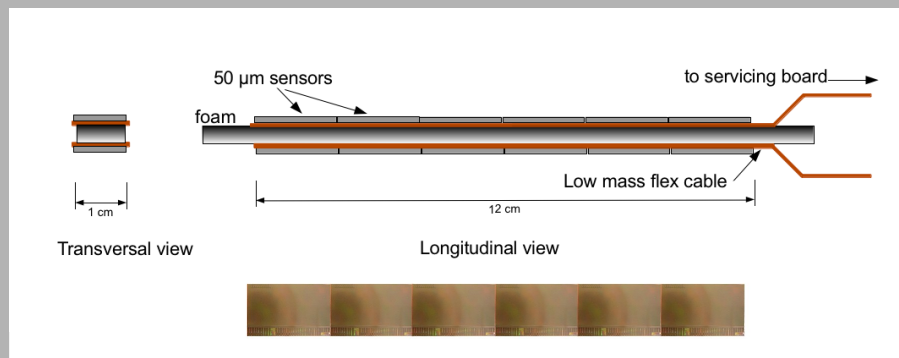
## ■ In a vertex detector

- x Opposite constraints
  - Electrical connection + Mechanical support + Power dissipation
  - Material budget
- x ILC goals
  - Single point resolution  $\sim 3\mu\text{m}$
  - Double sided ladder
  - Material budget  $< 0.3\% X_0$

## ■ PLUME project

Strasbourg, DESY, Oxford, Bristol, ...

- x Assume
  - air flow cooling
  - Double sided ladders
  - Power cycling operation
  - Ladder = 2 modules on SiC
  - Sensors thinned down to  $50\mu\text{m}$
- x 2009:
  - Module = 2 MIMOSA 20,  $2 \times 1\text{cm}^2$  (analog sensors)
  - Ladder =  $0.6\% X_0$
  - Test beam for pointing accuracy study (start next week!)
- x 2010 - 2012
  - Module = 6 large MIMOSA
  - Decrease material budget
  - Many tests ahead
    - Mechanical stability
    - Thermal distribution
    - Alignment





■ MIMOSA 26 as a fast binary output sensor

- x Large scale 2cm<sup>2</sup>
- x Reaches performances of smaller size precursors
- x Matches Beam Telescope + certain vertex detectors requirements

■ Developments over the next few years

- x Known roadmap to match tighter requirements
- x Integration issue studies starting, should provide ladder demonstrator  $\ll \% X_0$

ADDITIONAL  
SLIDES